

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Shunpei Yamazaki et al. Art Unit : 2629
Serial No. : 09/504,235 Examiner : David L. Lewis
Filed : February 15, 2000 Conf. No. : 7610
Title : METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE

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Commissioner for Patents
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INFORMATION DISCLOSURE STATEMENT

Applicants request consideration of the references listed on the attached PTO-1449 form.

Copies of any listed U.S. patents can be provided upon request.

This filing is being made with the filing of a Request for Continued Examination. No fee is required.

Respectfully submitted,

Date: February 1, 2007



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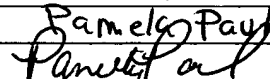
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CERTIFICATE OF HANDCARRY

I hereby certify that this correspondence is being delivered by hand on the date indicated below and is addressed to the U.S. Patent and Trademark Office, Office of Petitions, 600 Dulany Street, Madison West, 7C49, Alexandria, VA 22313.

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Substitute Form PTO-1449 (Modified)	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 07977-008004	Application No. 09/504,235
Information Disclosure Statement by Applicant (Use several sheets if necessary) (37 CFR §1.98(b))		Applicant Shunpei Yamazaki et al.	
		Filing Date February 15, 2000	Group Art Unit 2629

U.S. Patent Documents							
Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA	3,877,790	04/15/1975	ROBINSON			09/18/1972
	AB	4,409,268	10/11/1983	INOUE et al.			11/05/1980
	AC	5,264,953	11/23/1993	HIRAI et al.			12/20/1991
	AD	5,504,020	04/02/1996	AOMORI et al.			09/16/1994
	AE	5,519,521	05/21/1996	OKIMOTO et al.			05/17/1993
	AF						
	AG						
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	AI						
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Foreign Patent Documents or Published Foreign Patent Applications								
Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation	
							Yes	No
	AL							
	AM							
	AN							
	AO							
	AP							

Other Documents (include Author, Title, Date, and Place of Publication)		
Examiner Initial	Desig. ID	Document
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EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	